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|-------|-------|---|--|------------------|---------|------------------|
| S1 | 0 | ((pattern with correct\$3 with mask with semiconductor) and (variable same correct\$3 same line same width same overlap\$4 same grid same misalignment)).clm. | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2007/09/17 17:12 |
| S2 | 0 | ((pattern with correct\$3 with mask with semiconductor) and (variable same correct\$3 same line same width same overlap\$4 same misalignment)).clm. | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2007/09/17 17:11 |
| S3 | 0 | ((variable same correct\$3 same line same width same overlap\$4 same misalignment)).clm. | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2007/09/17 17:11 |
| S4 | 0 | ((variable same line same width same overlap\$4 same misalignment)).clm. | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2007/09/17 17:11 |
| S5 | 0 | ((pattern with correct\$3 with mask with semiconductor) and (line same width same overlap\$4)).clm. | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2007/09/17 17:21 |
| S6 | 24296 | 382/144,145,147.ccls. 438/16,401,462,800.ccls. 716/2,19,20,21.ccls. 356/237.4,237.5,394.ccls. 430/4,5,30.ccls. 700/96,97,105,120,121.ccls. | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2007/09/18 11:58 |
| S7 | 373 | ((pattern with mask) and ((correct\$3 or fix\$3 or chang\$3 or adjust\$3) same line same width same overlap\$4)) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2007/09/17 17:31 |

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| S8 | 82 | S6 and S7 | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2007/09/17 17:27 |
| S9 | 4484 | ((semiconductor or wafer or mask or IC) and ((correct\$3 or fix\$3 or chang\$3 or adjust\$3) same line same width same overlap\$4)) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2007/09/17 17:33 |
| S10 | 100 | S6 and S9 | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2007/09/17 17:31 |
| S11 | 119 | ((semiconductor or wafer or mask or IC) and ((correct\$3 or fix\$3 or chang\$3 or adjust\$3) same line same width same overlap\$4 same (misalign\$3 or askew or skew\$3 or uneven or asymmetric\$3))) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2007/09/17 17:35 |
| S12 | 4 | S6 and S11 | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2007/09/17 17:35 |
| S13 | 7 | ((pattern with mask) and ((correct\$3 or fix\$3 or chang\$3 or adjust\$3) same line same width same overlap\$4 same (misalign\$3 or askew or skew\$3 or uneven or asymmetric\$3))) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2007/09/17 17:36 |
| S14 | 12 | ((pattern with mask) and ((correct\$3 or fix\$3 or chang\$3 or adjust\$3) same width same overlap\$4 same (misalign\$3 or askew or skew\$3 or uneven or asymmetric\$3))) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2007/09/17 17:35 |

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| S15 | 35 | ((pattern with mask) and ((correct\$3 or fix\$3 or chang\$3 or adjust\$3) same line same width same (overlap\$4 or join\$3 or connect\$3 or overlay\$3 or intersect\$3) same (misalign\$3 or askew or skew\$3 or uneven or asymmetric\$3))) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2007/09/17 17:37 |
| S16 | 774 | ((semiconductor or wafer or mask or IC) and ((correct\$3 or fix\$3 or chang\$3 or adjust\$3) same line same width same (overlap\$4 or join\$3 or connect\$3 or overlay\$3 or intersect\$3) same (misalign\$3 or askew or skew\$3 or uneven or asymmetric\$3))) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2007/09/17 17:38 |
| S17 | 8 | S6 and S16 | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2007/09/17 17:38 |

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- #3 (((semiconductor or wafer or mask or ic) and ((correct* or fix* or chang* or adjust*) <paragraph> line <paragraph> width <paragraph> (overlap* or join* or connect* or overlay* or intersect*) <paragraph> (misalign* or askew or skew* or uneven or asymmetric*)))<in>metadata)

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IET JNL IET Journal or Magazine

IEEE CNF IEEE Conference Proceeding

IET CNF IET Conference Proceeding

IEEE STD IEEE Standard

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- ☐ 1. Driving spectral resolution to the noise limit in semiconductor gamma de Lachish, U.;
[Nuclear Science, IEEE Transactions on](#)
Volume 48, Issue 3, Part 1, June 2001 Page(s):520 - 523
Digital Object Identifier 10.1109/23.940110
[AbstractPlus](#) | [References](#) | Full Text: [PDF\(76 KB\)](#) IEEE JNL
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- ☐ 2. Driving spectral resolution to the noise limit in semiconductor gamma de Lachish, U.;
[Nuclear Science Symposium Conference Record, 2000 IEEE](#)
Volume 2, 15-20 Oct. 2000 Page(s):9/175 - 9/178 vol.2
Digital Object Identifier 10.1109/NSSMIC.2000.949893
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Inventor Name Search Result

Your Search was:

Last Name = HASHIMOTO

First Name = KOJI

| Application# | Patent# | Status | Date Filed | Title | Inventor Name |
|-----------------|----------------|--------|------------|--|-----------------|
| <u>06724592</u> | Not Issued | 161 | 04/18/1985 | METHODS FOR PREPARATION OF OVERLAID METAL LAYERS | HASHIMOTO, KOJI |
| <u>06837812</u> | Not Issued | 166 | 03/10/1986 | HIGHLY CORROSION-RESISTANT AND HIGH STRENGTH ALUMINUM ALLOYS | HASHIMOTO, KOJI |
| <u>06838651</u> | Not Issued | 166 | 03/11/1986 | HIGHLY CORROSION-RESISTANT AMORPHOUS ALLOY | HASHIMOTO, KOJI |
| <u>06844902</u> | Not Issued | 166 | 03/27/1986 | HIGHLY CORROSION-RESISTANT AMORPHOUS ALLOY | HASHIMOTO, KOJI |
| <u>06861371</u> | <u>4772773</u> | 150 | 02/18/1986 | METHODS FOR PREPARATION OF OVERLAID AMORPHOUS ALLOY LAYERS | HASHIMOTO, KOJI |
| <u>06892827</u> | <u>4770949</u> | 150 | 08/04/1986 | SURFACE ACTIVATED AMORPHOUS AND SUPERSATURATED SOLID SOLUTION ALLOYS FOR ELECTRODES IN THE ELECTROLYSIS OF SOLUTIONS AND THE METHOD FOR THEIR SURFACE ACTIVATION | HASHIMOTO, KOJI |
| <u>07098387</u> | Not Issued | 166 | 09/18/1987 | SURFACE ACTIVATED SURFACE ALLOY ELECTRODES AND A PROCESS FOR PREPARING THEM | HASHIMOTO, KOJI |
| <u>07098391</u> | <u>4834806</u> | 150 | 09/18/1987 | CORROSION-RESISTANTSTROCTURE STRUCTURE COMPRISING A METALLK SURFACE AND AN SURFACE BONDED THEREEUPON | HASHIMOTO, KOJI |

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|-----------------|----------------|-----|------------|--|-----------------|
| <u>07099371</u> | <u>4743314</u> | 150 | 09/21/1987 | HIGHLY CORROSION-RESISTANT AMORPHOUS ALLOY OF NI-CU-TI WITH TA AND/OR NB | HASHIMOTO, KOJI |
| <u>07162987</u> | <u>4877574</u> | 150 | 03/02/1988 | METHOD OF AND APPARATUS FOR CONTROLLING POWER OF NATURAL CIRCULATION REACTOR | HASHIMOTO, KOJI |
| <u>07183553</u> | <u>4880482</u> | 250 | 04/19/1988 | HIGHLY CORROSION-RESISTANT AMORPHOUS ALLOY | HASHIMOTO, KOJI |
| <u>07183981</u> | Not Issued | 166 | 04/20/1988 | AMORPHOUS ALUMINUM ALLOYS | HASHIMOTO, KOJI |
| <u>07195732</u> | <u>4868073</u> | 150 | 05/16/1988 | HIGHLY ACTIVE CATALYST AND HIGHLY ACTIVE ELECTRODE MADE OF THIS CATALYST | HASHIMOTO, KOJI |
| <u>07236262</u> | Not Issued | 161 | 08/23/1988 | HIGHLY CORROSION-RESISTANT AND HIGH-STRENGTH ALUMINUM ALLOYS | HASHIMOTO, KOJI |
| <u>07275642</u> | <u>4968363</u> | 250 | 11/22/1988 | METHOD OF PREVENTING CORROSION OF A MATERIAL AGAINST HYDROCHLORIC ACID | HASHIMOTO, KOJI |
| <u>07306264</u> | Not Issued | 166 | 02/01/1989 | HIGHLY CORROSION-RESISTANT AMORPHOUS ALLOY | HASHIMOTO, KOJI |
| <u>07339611</u> | Not Issued | 166 | 02/24/1989 | AMORPHOUS ALLOY HAVING HIGH CORROSION RESISTANCE | HASHIMOTO, KOJI |
| <u>07420903</u> | <u>5015352</u> | 150 | 10/13/1989 | PREPARATION METHOD FOR AMORPHOUS SUPERLATTICE ALLOYS | HASHIMOTO, KOJI |
| <u>07420930</u> | <u>5076865</u> | 250 | 10/13/1989 | AMORPHOUS ALUMINUM ALLOYS | HASHIMOTO, KOJI |
| <u>07440592</u> | <u>5087401</u> | 150 | 11/22/1989 | PROCESS FOR PREPARING POLYESTER FILAMENTARY MATERIAL | HASHIMOTO, KOJI |
| <u>07453966</u> | Not Issued | 161 | 12/20/1989 | SURFACE ACTIVATED SURFACE ALLOY ELECTRODES AND A PROCESS FOR PREPARING THEM | HASHIMOTO, KOJI |
| <u>07454412</u> | <u>5030300</u> | 250 | 12/21/1989 | AMORPHOUS ALUMINUM ALLOYS | HASHIMOTO, KOJI |
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|-----------------|----------------|-----|------------|--|-----------------|
| <u>07481718</u> | <u>4964967</u> | 150 | 02/16/1990 | SURFACE ACTIVATED ALLOY ELECTRODES AND PROCESS FOR PREPARING THEM | HASHIMOTO, KOJI |
| <u>07529727</u> | Not Issued | 161 | 05/23/1990 | STABILIZED SPORE-FORMING VIABLE MICROORGANISMS PREPARATION, ITS PRODUCTION AND PELLET THEREOF | HASHIMOTO, KOJI |
| <u>07592368</u> | <u>5123980</u> | 150 | 10/03/1990 | SPUTTER DEPOSITED AMORPHOUS TITANIUM ALUMIUN ALLOYS | HASHIMOTO, KOJI |
| <u>07593745</u> | <u>5041175</u> | 150 | 10/05/1990 | AMORPHOUS ALUMINUM ALLOYS | HASHIMOTO, KOJI |
| <u>07662283</u> | Not Issued | 161 | 02/28/1991 | AMORPHOUS ALLOY CATALYSTS FOR CONVERSION OF CARBON DIOXIDE | HASHIMOTO, KOJI |
| <u>07662286</u> | Not Issued | 161 | 02/28/1991 | AMORPHOUS ALLOY CATALYSTS FOR DECOMPOSITION OF FLONS | HASHIMOTO, KOJI |
| <u>07758851</u> | Not Issued | 161 | 09/12/1991 | CATALYST MATERIAL AND METHOD FOR DECOMPOSITION OF CHLOROFLUOROCARBONS | HASHIMOTO, KOJI |
| <u>07766064</u> | Not Issued | 166 | 09/27/1991 | GENE DETECTION METHOD | HASHIMOTO, KOJI |
| <u>07779985</u> | Not Issued | 166 | 10/21/1991 | AMORPHOUS ALUMINUM ALLOYS | HASHIMOTO, KOJI |
| <u>07830847</u> | <u>5264498</u> | 250 | 02/04/1992 | POLYCARBONATE RESIN COMPOSITION | HASHIMOTO, KOJI |
| <u>07853436</u> | <u>5468576</u> | 150 | 03/18/1992 | METHOD FOR MANUFACTURING EXPOSURE MASK AND THE EXPOSURE MASK | HASHIMOTO, KOJI |
| <u>07856159</u> | <u>5326736</u> | 250 | 04/01/1992 | AMORPHOUS ALLOY CATALYSTS FOR CONVERSION OF EXHAUST GASES TO HARMLESS GASES | HASHIMOTO, KOJI |
| <u>07867127</u> | <u>5245112</u> | 250 | 04/10/1992 | METHOD FOR DECOMPOSITION OF CHLOROFLUORCARBONS | HASHIMOTO, KOJI |
| <u>07867527</u> | <u>5283059</u> | 150 | 04/13/1992 | PROCESS FOR PRODUCING A STABILIZED STORE-FORMING VIABLE MICROORGANISMS PREPARATION CONTAINING BACILUS CEREUS | HASHIMOTO, KOJI |

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|--------------------------|-------------------------|-----|------------|---|-----------------|
| 07869629 | 5220108 | 250 | 04/16/1992 | AMORPHOUS ALLOY CATALYSTS FOR DECOMPOSITION OF FLONS | HASHIMOTO, KOJI |
| 07878567 | Not Issued | 166 | 05/05/1992 | HIGH CORROSION-RESISTANT AMORPHOUS ALLOYS | HASHIMOTO, KOJI |
| 07880047 | 5217332 | 150 | 05/07/1992 | DRILL BIT FOR ADVANCED MATERIALS | HASHIMOTO, KOJI |
| 07892477 | Not Issued | 161 | 06/02/1992 | HIGHLY CORROSION-RESISTANT AMORPHOUS ALLOY | HASHIMOTO, KOJI |
| 07913421 | 5248754 | 150 | 07/15/1992 | PROCESS FOR CONTINUOUS PRODUCTION OF POLYCARBONATE OLIGOMER | HASHIMOTO, KOJI |
| 07914027 | 5634989 | 150 | 07/15/1992 | AMORPHOUS NICKEL ALLOY HAVING HIGH CORROSION RESISTANCE | HASHIMOTO, KOJI |
| 07955256 | 5319324 | 150 | 10/01/1992 | METHOD OF DIRECT BONDING OF CRYSTALS AND CRYSTAL DEVICES | HASHIMOTO, KOJI |
| 07961783 | Not Issued | 166 | 10/15/1992 | HIGH CORROSION RESISTANT AMORPHOUS ALLOYS | HASHIMOTO, KOJI |
| 08007577 | Not Issued | 163 | 01/22/1993 | HIGHLY CORROSION RESISTANT AMORPHOUS ALUMINUM ALLOY | HASHIMOTO, KOJI |
| 08008758 | Not Issued | 163 | 01/25/1993 | HIGHLY CORROSION RESISTANT AMORPHOUS ALUMINUM ALLOY | HASHIMOTO, KOJI |
| 08009397 | Not Issued | 161 | 01/27/1993 | AMORPHOUS ALUMINUM ALLOYS | HASHIMOTO, KOJI |
| 08041427 | 5364711 | 150 | 03/31/1993 | FUEL CELL | HASHIMOTO, KOJI |
| 08044534 | Not Issued | 166 | 04/07/1993 | AMORPHOUS ALLOYS RESISTANT AGAINST HOT CORROSION | HASHIMOTO, KOJI |
| 08073623 | Not Issued | 166 | 06/07/1993 | HIGH CORROSION-RESISTANT AMORPHOUS ALLOYS | HASHIMOTO, KOJI |

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Inventor Name Search Result

Your Search was:

Last Name = USUI

First Name = SATOSHI

| Application# | Patent# | Status | Date Filed | Title | Inventor Name |
|-----------------|----------------|--------|------------|---|---------------|
| <u>06945298</u> | <u>4746536</u> | 150 | 12/17/1986 | METHOD FOR SELECTIVE CHEMICAL PLATING | USUI, SATOSHI |
| <u>07987593</u> | <u>5328541</u> | 250 | 12/09/1992 | METHOD OF WELDING TUBULAR PRODUCTS OF POLYARYLENE SULFIDE AND WELDED TUBULAR STRUCTURE | USUI, SATOSHI |
| <u>08364693</u> | Not Issued | 161 | 12/28/1994 | APPARATUS AND METHOD FOR WELDING THERMOPLASTIC RESIN MEMBERS | USUI, SATOSHI |
| <u>08365285</u> | Not Issued | 161 | 12/28/1994 | METHOD FOR WELDING TUBULAR MEMBERS | USUI, SATOSHI |
| <u>08370485</u> | Not Issued | 161 | 01/09/1995 | APPARATUS AND METHOD FOR WELDING TUBULAR MEMBERS | USUI, SATOSHI |
| <u>09137684</u> | <u>6136478</u> | 150 | 08/21/1998 | MASK PATTERN CORRECTION METHOD AND EXPOSURE MASK TO BE USED FOR SUCH A METHOD | USUI, SATOSHI |
| <u>09155546</u> | Not Issued | 164 | 09/25/1998 | RESIN COMPOSITION | USUI, SATOSHI |
| <u>09650672</u> | <u>6526250</u> | 150 | 08/30/2000 | TRANSFER FIXING DEVICE, IMAGE BEARING AND CONVEYING BODY, AND IMAGE FORMING APPARATUS | USUI, SATOSHI |
| <u>09662219</u> | Not Issued | 71 | 09/14/2000 | Pattern correcting method of mask for manufacturing a semiconductor device and recording medium having recorded its pattern correcting method | USUI, SATOSHI |
| <u>09815004</u> | <u>6727026</u> | 150 | 03/23/2001 | SEMICONDUCTOR | USUI, SATOSHI |

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|-----------------|----------------|-----|------------|---|---------------|
| | | | | INTEGRATED CIRCUIT PATTERNS | |
| <u>09985810</u> | <u>6617083</u> | 150 | 11/06/2001 | METHOD OF CORRECTING MASK PATTERNS | USUI, SATOSHI |
| <u>10084386</u> | Not Issued | 164 | 02/28/2002 | HIGH PRESSURE FUEL PUMP FOR INTERNAL COMBUSTION ENGINE | USUI, SATOSHI |
| <u>10127770</u> | <u>6622296</u> | 150 | 04/23/2002 | EXPOSURE MASK PATTERN CORRECTION METHOD, PATTERN FORMATION METHOD, AND A PROGRAM PRODUCT FOR OPERATING A COMPUTER | USUI, SATOSHI |
| <u>10274034</u> | <u>7165534</u> | 150 | 10/21/2002 | FUEL FEED SYSTEM | USUI, SATOSHI |
| <u>10442203</u> | <u>7152583</u> | 150 | 05/21/2003 | HIGH-PRESSURE FUEL PUMP | USUI, SATOSHI |
| <u>10614206</u> | Not Issued | 161 | 07/08/2003 | HIGH PRESSURE FUEL PUMP FOR INTERNAL COMBUSTION ENGINE | USUI, SATOSHI |
| <u>10896039</u> | <u>7124738</u> | 150 | 07/22/2004 | DAMPER MECHANISM AND HIGH PRESSURE FUEL PUMP | USUI, SATOSHI |
| <u>10975001</u> | Not Issued | 30 | 10/28/2004 | Image information processing system, image information processing apparatus, image information outputting method, code information processing apparatus and program thereof | USUI, SATOSHI |
| <u>10975412</u> | Not Issued | 30 | 10/29/2004 | Image outputting system, image processing apparatus, image processing method and program thereof | USUI, SATOSHI |
| <u>11217444</u> | Not Issued | 61 | 09/02/2005 | Controlling apparatus of variable capacity type fuel pump and fuel supply system | USUI, SATOSHI |
| <u>11219674</u> | Not Issued | 30 | 09/07/2005 | Index sheet, picture case, image processing apparatus, image processing method and storage medium storing program | USUI, SATOSHI |
| <u>11354851</u> | Not Issued | 61 | 02/16/2006 | Electromagnetic drive mechanism and a high-pressure fuel supply pump | USUI, SATOSHI |
| <u>11409062</u> | Not Issued | 20 | 04/24/2006 | High pressure fuel pump for internal combustion engine | USUI, SATOSHI |
| <u>11546430</u> | Not | 41 | 10/12/2006 | Damper mechanism and high | USUI, SATOSHI |

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|--------------------------|------------|----|------------|--|---------------|
| | Issued | | | pressure fuel pump | |
| 11582396 | Not Issued | 41 | 10/18/2006 | High-pressure fuel supply system using variable displacement fuel pump | USUI, SATOSHI |
| 11599468 | Not Issued | 25 | 11/15/2006 | High-pressure fuel pump | USUI, SATOSHI |
| 11622170 | Not Issued | 41 | 01/11/2007 | High pressure fuel pump provided with damper | USUI, SATOSHI |
| 11780940 | Not Issued | 17 | 07/20/2007 | High-Pressure Fuel Pump | USUI, SATOSHI |
| 11835544 | Not Issued | 19 | 08/08/2007 | High-Pressure Fuel Supply Pump | USUI, SATOSHI |

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Inventor Name Search Result

Your Search was:

Last Name = YOSHIKAWA

First Name = KEI

| Application# | Patent# | Status | Date Filed | Title | Inventor Name |
|--------------------------|-------------------------|--------|------------|---|--------------------|
| 09662219 | Not Issued | 71 | 09/14/2000 | Pattern correcting method of mask for manufacturing a semiconductor device and recording medium having recorded its pattern correcting method | YOSHIKAWA, KEI |
| 10107298 | 7208423 | 150 | 03/28/2002 | SEMICONDUCTOR DEVICE FABRICATION METHOD AND SEMICONDUCTOR DEVICE | YOSHIKAWA, KEI |
| 11643907 | Not Issued | 30 | 12/22/2006 | Semiconductor device fabrication method and semiconductor device | YOSHIKAWA, KEI |
| 07470028 | Not Issued | 166 | 01/25/1990 | AQUEOUS RESIN COMPOSITION | YOSHIKAWA, KEIGO |
| 07884882 | Not Issued | 161 | 05/18/1992 | AQUEOUS RESIN COMPOSITION | YOSHIKAWA, KEIGO |
| 06592588 | 4566163 | 150 | 03/23/1984 | AUTOMATIC SUPERVISORY SYSTEM FOR A WARPER | YOSHIKAWA, KEIJI |
| 07823364 | 5242224 | 150 | 01/21/1992 | TEMPERATURE MONITORING UNIT | YOSHIKAWA, KEIJI |
| 09763130 | 6452056 | 250 | 02/20/2001 | PROCESS FOR THE PREPARATION OF FLUOROBENZYL DERIVATIVES | YOSHIKAWA, KEISUKE |
| 09897077 | 6756793 | 150 | 07/03/2001 | CAPACITANCE TYPE MOISTURE SENSOR AND METHOD OF PRODUCING THE SAME | YOSHIKAWA, KEISUKE |
| 10781947 | 7064011 | 150 | 02/20/2004 | SEMICONDUCTOR DEVICE FABRICATING APPARATUS AND SEMICONDUCTOR DEVICE FABRICATING | YOSHIKAWA, KEISUKE |

| | | | | METHOD | |
|-----------------|----------------|-----|------------|--|--------------------|
| <u>11000905</u> | <u>7268191</u> | 150 | 12/02/2004 | METHOD FOR PRODUCING EPOXY RESIN COMPOSITION FOR SEMICONDUCTOR ENCAPSULATION AND EPOXY RESIN COMPOSITION FOR SEMICONDUCTOR ENCAPSULATION AND SEMICONDUCTOR DEVICE OBTAINED THEREBY | YOSHIKAWA, KEISUKE |
| <u>11012126</u> | <u>7132755</u> | 150 | 12/16/2004 | ADHESIVE FILM FOR MANUFACTURING SEMICONDUCTOR DEVICE | YOSHIKAWA, KEISUKE |
| <u>11115307</u> | <u>7262514</u> | 150 | 04/27/2005 | EPOXY RESIN COMPOSITION FOR SEMICONDUCTOR ENCAPSULATION, SEMICONDUCTOR DEVICE USING THE SAME, AND PROCESS FOR PRODUCING SEMICONDUCTOR DEVICE | YOSHIKAWA, KEISUKE |
| <u>11362783</u> | Not Issued | 61 | 02/28/2006 | Semiconductor device fabricating apparatus and semiconductor device fabricating method | YOSHIKAWA, KEISUKE |
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